



Docket No.: 2342-0144PUS1
(PATENT)

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Takashi OZAKI et al.

Application No.: 10\549,938

Confirmation No.: N/A

Filed: September 20, 2005

Art Unit: N/A

For: PRODUCING METHOD OF SEMICONDUCTOR
DEVICE AND SUBSTRATE PROCESSING
APPARATUS

Examiner: Not Yet Assigned

LETTER

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

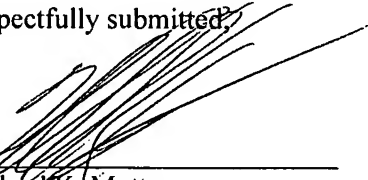
In connection with the above-identified application, enclosed herewith are copies of the documents that were cited in the International Search Report and listed on the Form PTO-SB08 filed with the Information Disclosure Statement on September 20, 2005.

The PTO is requested to make these documents of record in the file of the present application and to return the initialed Form PTO-1449 to the undersigned.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to our Deposit Account No. 02-2448 for any additional fees required under 37 C.F.R. § 1.16 or under § 1.17; particularly, extension of time fees.

Dated: December 20, 2005

Respectfully submitted,

By 
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Attachments: Documents cited in Search Report (5)